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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: I-Sheng Liu et al.
Title: SOURCE/DRAIN ADJUST IMPLANT
Application No.: 10/753,673 Filing Date: January 7, 2004
Examiner: Johannes P. Mondt Group Art Unit: 2826
Docket No.: M-15281US Confirmation No. 6785

Irvine, California
July 25, 2005

Via Facsimile to (571) 273-8300

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

TRANSMITTAL OF FORMAL DRAWINGS

As requested by the Examiner in the Office Action dated February 25, 2005, enclosed herewith are the formal drawings (2 sheets) to be filed in the above-referenced patent application. If you have any questions, please do not hesitate contacting the undersigned counsel for applicant.

Certificate of Mailing/Transmission
I hereby certify that this correspondence is being transmitted by both first class mail and addressed to Mail Stop, Commissioner of Patents, P. O. Box 1450, Alexandria, VA 22313-1450 and via facsimile.

Sandra L. Carr 7-25-05
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Respectfully submitted,

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